



11-16-04

EV486245729

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/052,313
Confirmation No8400
Filing Date January 18, 2002
5 InventorHodges et al.
Applicant.....Hewlett-Packard Company
Group Art Unit2823
ExaminerLee, Hsien Ming
Attorney's Docket No. 10004054-1
10 Title: "Semiconductor Device with Deposited Oxide"

RESPONSE TO OFFICE ACTION DATED JULY 15, 2004

To: Commissioner of Patents and Trademarks,
P.O. Box 1450
Alexandria, VA 22313-1450
15
From: Dmitry Milikovsky
(858) 655-3251
Hewlett-Packard Company
Intellectual Property Administration
20 P.O. Box 272400
Fort Collins, CO 80527-2400

This communication is in response to the Office Action dated July 15, 2004, for which a three-month shortened statutory period for response is set for
25 October 15, 2004. A one-month extension of time is being filed herewith.
Please amend the above-identified application in accordance the directions set forth below.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

30 **Remarks** begin on page 7 of this paper.